L Number	Hits	Search Text	DB	Time stamp
1	359474	etch\$3	USPAT;	2004/09/21 15:49
			US-PGPUB,	
			JPO	
2	144372	lithograph\$7 or photolithograph\$7	USPAT;	2004/09/21 15:49
-	111372	maiography of photonalography	US-PGPUB;	2004/05/21 15.45
			ло	
3	392327	mask\$3		2004/00/01 15:50
3	392327	mask\$5	USPAT;	2004/09/21 15:50
			US-PGPUB;	
			ЈРО	
4	19124	minimum same resolution\$1	USPAT;	2004/09/21 15:51
			US-PGPUB;	
			ЛО	
5	1131220	pattern\$3	USPAT;	2004/09/21 15:51
			US-PGPUB;	200 11 05/21 15:51
7	260012	01	JPO	0004/00/01 15 51
	260912	spacer\$1	USPAT;	2004/09/21 15:51
			US-PGPUB;	
			ЛРО	
	7251	hard adj2 mask\$3	USPAT;	2004/09/21 15:52
			US-PGPUB;	
			ЛО	
8	307537	anti-reflect\$4 or antireflect\$4 or arc	USPAT;	2004/09/21 15:52
			US-PGPUB;	200 1103721 13.32
			ло	l :
9	699	(hard adj2 mask\$3) same (anti-reflect\$4 or antireflect\$4 or arc)		2004/00/21 15:52
	099	(nard adj2 mask\$3) same (and-reflect\$4 or andreflect\$4 or arc)	USPAT;	2004/09/21 15:53
			US-PGPUB;	
• •			ЈРО	
10	1664	(lithograph\$7 or photolithograph\$7) same (minimum same resolution\$1)	USPAT;	2004/09/21 15:53
			US-PGPUB;	
			ЛРО	
11	125640	etch\$3 same mask\$3	USPAT;	2004/09/21 15:53
			US-PGPUB;	200 1101121 13:33
			JPO	
12	21194	etch\$3 same spacer\$1		2004/00/21 15:52
	21174	etchos same spaceron	USPAT;	2004/09/21 15:53
			US-PGPUB;	
			ЛО	
13	371	((lithograph\$7 or photolithograph\$7) same (minimum same	USPAT;	2004/09/21 15:54
		resolution\$1)) and (etch\$3 same mask\$3) and (etch\$3 same spacer\$1)	US-PGPUB;	
			ЛО	
14	39	(anti-reflect\$4 or antireflect\$4 or arc) and (((lithograph\$7 or	USPAT;	2004/09/21 15:54
		photolithograph\$7) same (minimum same resolution\$1)) and (etch\$3	US-PGPUB;	
		same mask\$3) and (etch\$3 same spacer\$1))	ло ле	
15	9	((((lithograph\$7 or photolithograph\$7) same (minimum same	USPAT;	2004/09/21 15:54
	,	resolution\$1)) and (etch\$3 same mask\$3) and (etch\$3 same spacer\$1))	,	2004/09/21 15:54
			US-PGPUB;	
16	20	and ((hard adj2 mask\$3) same (anti-reflect\$4 or antireflect\$4 or arc))	ЛРО	
10	30	((anti-reflect\$4 or antireflect\$4 or arc) and (((lithograph\$7 or	USPAT;	2004/09/21 15:54
		photolithograph\$7) same (minimum same resolution\$1)) and (etch\$3	US-PGPUB;	
l		same mask\$3) and (etch\$3 same spacer\$1))) not ((((lithograph\$7 or	ЛО	
		photolithograph\$7) same (minimum same resolution\$1)) and (etch\$3		
		same mask\$3) and (etch\$3 same spacer\$1)) and ((hard adj2 mask\$3)		
		same (anti-reflect\$4 or antireflect\$4 or arc)))		
17	332	(((lithograph\$7 or photolithograph\$7) same (minimum same	USPAT;	2004/09/21 15:55
	332	resolution\$1)) and (etch\$3 same mask\$3) and (etch\$3 same spacer\$1))		2004/03/21 13:33
i		not ((anti-reflect\$4 or antireflect\$4 or arc) and (((lithograph\$7 or	US-PGPUB;	
			ΡΟ	
		photolithograph\$7) same (minimum same resolution\$1)) and (etch\$3		
		same mask\$3) and (etch\$3 same spacer\$1)))		